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**Application Information**

Title Line One:: EXPOSURE METHOD AND APPARATUS, AND  
Title Line Two:: METHOD OF FABRICATING A DEVICE  
Title Line Three::  
Title Line Four::

Total Drawing Sheets:: 7  
Docket Number:: 107629

### Continuity Information

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>This application is a::  
Application One::  
Filing Date::  
Patent Number::  
which is a::  
>>Application Two::  
Filing Date::  
Patent Number::
```

### Prior Foreign Applications

Foreign Application One::: JP 11-299331  
Filing Date::: October 21, 1999  
Country::: Japan  
Priority Claimed::: yes  
Foreign Application Two:::  
Filing Date:::  
Country:::  
Priority Claimed:::  
Foreign Application Three:::  
Filing Date:::  
Country:::  
Priority Claimed:::